

# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

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Docket Number (Optional)

CS-00-197/199

Application Number

10/002,987

Applicant

Feng Dai et al.

Filing Date

11/30/01

Group Art Unit

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE & APPROPRIATE
REP	6197691	3/6/01	Lee	438	691	11/15/99
REP	6057210	5/2/00	Yang et al.	438	427	4/21/98
REP	6015755	1/18/00	Chen et al.	438	692	9/29/98
REP	4954459	9/4/90	Avanzino et al.	437	228	7/3/89
REP	5961794	10/5/99	Morita	204	192.34	10/4/96
REP	5923993	7/13/99	Sahota	438	427	12/17/97
REP	6057207	5/2/00	Lin et al.	438	424	3/25/98
REP	6103581	8/15/00	Lin et al.	438	296	11/27/98
REP	6004863	12/21/99	Jang	438	427	5/6/98
PRO-PENDING U.S. Patent Application	09/803,187		(CS-00-138) Keong et al.			3/12/01

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
					YES NO
				C 2800 MAIL ROOM	RECEIVED

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

Pamela Parker

DATE CONSIDERED

4-23-03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.